	ъ#	Hits	Search Text
1	L1	251	((optical adj proximity adj effect) or ope) same (mask or reticle)
2	L2		((optical adj proximity adj effect) or ope or CD or (critical adj dimension) or (proximity adj effect)) same (mask or reticle)
3	L3	3529	((optical adj proximity adj effect) or ope or CD or (critical adj dimension) or (proximity adj effect)) near6 (correct\$3 or improv\$3)
4	L4	797	2 and 3
5	L5	431	4 and (355/\$.ccls. or 430/\$.ccls.)
6	L6	763482	pitch or dense or density
7	L7	257982	6 and (substrate or wafer)
8	L8	304	5 and 7
9	L9	66988	<pre>(correct\$3 or improving or sub-lithographic or non-resolvable or unresolvable or ("not print\$3")) with (feature or element)</pre>
10	L10	133	8 and 9
11	L11	38	5821014.uref.

Peto X